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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hidetoshi Narahara et al.  
Title: METHOD OF ANALYZING  
ELECTROMAGNETIC INTERFERENCE  
Docket No.: 32796



INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with Rule 56, applicants are aware of the publications listed in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,

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